

PATENT ASSIGNMENT

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT
CONVEYING PARTY DATA	
Name	Execution Date
Robert D Wieting	04/14/2010
RECEIVING PARTY DATA	
Name:	Stion Corporation
Street Address:	6321 San Ignacio Avenue
City:	San Jose
State/Country:	CALIFORNIA
Postal Code:	95119
PROPERTY NUMBERS Total: 1	
Property Type	Number
Application Number:	12568644
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ATTORNEY DOCKET NUMBER:	026335-004410US
NAME OF SUBMITTER:	Rosalinda M. Santos
Total Attachments: 1 source=004410US_Executed_Assignment_for_Recordaton_04152010#page1.tif	

OP \$40.00 12568644

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PATENT
REEL: 024239 FRAME: 0051

ASSIGNMENT OF PATENT APPLICATION

SOLE

WHEREAS, **Robert D. Wieting** of San Jose, CA, hereinafter referred to as "Assignor," is the inventor of the invention described and set forth in the below-identified application for United States Letters Patent:

Title of Invention: **LARGE SCALE METHOD AND FURNACE SYSTEM
FOR SELENIZATION OF THIN FILM
PHOTOVOLTAIC MATERIALS**

Date(s) of execution of Declaration:

Filing Date: **September 28, 2009**

Application No.: **12/568,644**; and

WHEREAS, **Stion Corporation**, located at 6321 San Ignacio Ave., San Jose, CA 95119, hereinafter referred to as "ASSIGNEE," is desirous of acquiring an interest in the invention and application and in any U.S. Letters Patent and Registrations which may be granted on the same;

For good and valuable consideration, receipt of which is hereby acknowledged by Assignor, Assignor has assigned, and by these presents does assign to Assignee all right, title and interest in and to the invention and application and to all foreign counterparts (including patent, utility model and industrial designs), and in and to any Letters Patent and Registrations which may hereafter be granted on any patent application claiming priority from the same in the United States and all countries throughout the world, and to claim the priority from the application as provided by the Paris Convention. The right, title and interest is to be held and enjoyed by Assignee and Assignee's successors and assigns as fully and exclusively as it would have been held and enjoyed by Assignor had this Assignment not been made, for the full term of any Letters Patent and Registrations which may be granted thereon, or of any division, renewal, continuation in whole or in part, substitution, conversion, reissue, prolongation or extension thereof.

Assignor further agrees that Assignor will, without charge to Assignor, but at Assignee's expense, (a) cooperate with Assignee in the prosecution of U.S. Patent applications and foreign counterparts on the invention and any improvements, (b) execute, verify, acknowledge and deliver all such further papers, including applications and instruments of transfer, and (c) perform such other acts as Assignee lawfully may request to obtain or maintain Letters Patent and Registrations for the invention and improvements in any and all countries, and to vest title thereto in Assignee, or Assignee's successors and assigns.

IN TESTIMONY WHEREOF, Assignor has signed his/her name on the date indicated.

Dated: 14 Apr 10


Robert D. Wieting

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